

## Journal Publications

1. J.B. Huang, S. Tung, C.M. Ho, C. Liu, and Y.C. Tai, "Improved Micro Thermal Shear-Stress Sensor," *IEEE Transactions on Instrumentation and Measurement*, Vol. 45, No. 2, pp. 570-574, 1996.
2. C. Liu, T. Tsao, and Y.C. Tai, "A High Yield Drying Process for Surface-micromachined Structures Using Magnetostatic Forces," *Journal of Sensors and Materials*, Vol. 11, No. 2, pp. 71-86, 1998.
3. C. Liu, "Development of Surface Micromachined Magnetic Actuators using Electroplated Permalloy," *Journal of Mechatronics*, pp.613-633, 1998.
4. C. Liu and R. Gamble, "Mass producible monolithic silicon probes for scanning probe microscopes," *J. Sensors and Actuators, A. Physical*, Vol. 71/3, pp. 233-237, 1998.
5. C. Liu, J. Huang, Z. Zhu, F. Jiang, S. Tung, Y.C. Tai, and C.M. Ho, "A Micromachined Flow Shear-stress Sensor Based on Thermal Transfer Principles," *IEEE Journal of Microelectromechanical Systems*, Vol. 8, No. 1, pp.90-99, 1999.
6. C. Liu and Y.C. Tai, "Sealing of micromachined cavities using chemical vapor deposition methods: characterization and optimization," *IEEE J. of Microelectromechanical Systems*, Vol. 8, No. 2, pp. 135-145, June 1999.
7. C. Liu, T. Tsao, V. Lee, J. Lu, Y. Yi, Y.C. Tai, and C.M. Ho, "Out of plane magnetic actuators with electroplated Permalloy for fluid dynamic control," *J. Sensors and Actuators*, Vol. 78, Issue 2-3, pp. 190-97, 1999.
8. Y. Yi and C. Liu, "Magnetic Actuation of Hinged Microstructures ", *Journal of Microelectromechanical Systems*, Vol. 8, No. 1, pp.10-17, March, 1999.
9. Y. Yi and C. Liu, "Assembly of micro optical devices using magnetic actuation," *J. Sensors and Actuators*, Vol. 78, Issue 2-3, pp. 205-11, 1999.
10. C. Liu and Y. Yi, "Micromachined magnetic actuators using electroplated Permalloy," *IEEE Trans. on Magnetics*, Vol. 35, No. 3, pp. 1976-85, May, 1999.
11. J. Zou, M. Balberg, C. Byrne, C. Liu, and D. Brady, "Effect of Etch Holes on the Optical Properties of Surface Micromachined Mirrors", *Journal of Microelectromechanical Systems*, Vol. 8, No. 4, pp. 506-513, December 1999.
12. Z. Zhu and C. Liu, "Simulation of anisotropic crystalline etching using a continuous cellular automata algorithm," *Journal Computer Modeling for Engineering and Science*, Vol. 1, No. 1, pp. 11-19, 2000.
13. D. Armani and C. Liu, "Microfabrication Technology for Polycaprolactone, A Biodegradable Polymer", *J. of Micromechanics and Microengineering*, 10, pp. 80-84, 2000.
14. Z. Zhu and C. Liu, "Micromachining process simulation using a continuous cellular automata method," *IEEE/ASME Journal of Microelectromechanical Systems*, Vol. 9, No. 2, pp. 252-61, 2000.
15. J. Zou, C. Liu, and J. Schutt-aïne, "Development of a wide-tuning-range two-parallel-plate tunable capacitor for integrated wireless communication system," *Int. Journal RF and Microwave CAE*, 11:322-329, 2001.
16. J. Zou, J. Chen, C. Liu, and J. Schutt-Aïne, "Plastic Deformation Magnetic Assembly (PDMA) of Out-Of-Plane Microstructures: Technology and Application," *IEEE/ASME J. of Microelectromechanical Systems*, Vol. 10, No. 2, pp. 302-309, June 2001.
17. S.J. Park, J. Chen, C. Liu, and J.G. Eden, "Arrays of microdischarge devices having 50-100um square pyramidal Si anodes and screen cathodes," *Electronics Letters*, Vol. 37, No. 3, pp.171-2, Feb 1, 2001.
18. M. Khoo and C. Liu, "Micro magnetic silicone elastomer membrane actuator", *J. Sensors and Actuators*, Vol. 89, No. 3, pp. 259-266, March, 2001.
19. S.J. Park, J. G. Eden, J. Chen, C. Liu, and J. Ewing, "Arrays of silicon microsidcharge devices with multicomponent dielectrics," *Optics Letters*, Vol. 26, No. 22, pp. 1773-1775, November 15, 2001.

20. S.J. Park, J.G. Eden, J. Chen, and C. Liu, "Independently addressable subarrays of silicon microdischarge devices: electrical characteristics of large (30x30) arrays and excitation of a phosphor," *Appl. Phys. Lett.*, Vol. 79, No. 13, pp. 2100-02, 2001.
21. S.J. Park, J. Chen, C. Liu, and J.G. Eden, "Silicon microdischarge devices having inverted pyramidal diodes: fabrication and performance of arrays", *Applied Physics Letters*, Vol. 78, No. 4, pp 419-421, Jan 22, 2001.
22. S.J. Park, J. Chen, C.J. Wagner, N.P. Ostrom, C. Liu, and J.G. Eden, "Microdischarge arrays: A new family of photonic devices", *IEEE J. Selected Topics in Quantum Electronics*, Vol. 8, No. 1, pp. 139-147, 2001.
23. M. Zhang, D. Bullen, S-W Chung, S. Hong, K. S. Ryu, Z. Fan, C. A. Mirkin, and C. Liu, "A MEMS Nanoplotter with High-Density Parallel Dip Pen Nanolithography (DPN) Probe Arrays", *J. of Nanotechnology*, Vol. 13, pp. 212-217, April 2002.
24. J. Chen, S. Park, Z. Fan, G. Eden, and C. Liu, "Development and characterization of Micromachined hollow cathode plasma display devices," *IEEE/ASME J. of Microelectromechanical Systems*, Vol. 11, No. 5, pp. 536-543, October 2002.
25. C. Xu, W. Lemon, and C. Liu, "Design and Fabrication of A High Density Metal Microelectrode Array for Neural Recording", *J. Sensors and Actuators*, Vol. A 96, Issue 1, pp. 78-85, January 2002.
26. L. Lu, K.S. Ryu, and C. Liu, "A Magnetic Microstirrer and Array for Microfluidic Mixing," *IEEE/ASME J. of Microelectromechanical Systems*, Vol. 11, No. 5, pp. 462-469, 2002.
27. Zhifang Fan, Jack Chen, Jun Zou, David Bullen, Chang Liu, and Fred Delcomyn, "Design and Fabrication of Artificial Lateral-Line Flow Sensors", *J. Micromechanics and Microengineering*, Vol. 12, No. 5, pp. 655-661, September 2002.
28. J.-C. Langer, J. Zou, C. Liu, and J. T. Bernhard, "Micromachined Reconfigurable out-of-plane microstrip patch antenna using MEMS plastic deformation magnetic actuation." *IEEE Microwave and Wireless Components Letters*, Vol. 13, No. 2, pp. 120-122, March 2003.
29. W. Sutomo, X. Wang, D. Bullen, S. K. Braden, C. Liu, "Development of An End-Point Detector for Parylene Deposition Process," *IEEE/ASME Journal of MEMS*, Vol. 12, No. 1, pp. 64-69, February 2003.
30. J. Chen, Z. Fan, J. Zou, J. Engel, and C. Liu, "Two Dimensional Micromachined Flow Sensor Array for Fluid Mechanics Studies," *Journal of Aerospace Engineering*, Vol. 16, No. 2, pp. 85-97, pp. 1067-1075, April 2003
31. Jun Zou, Chang Liu, Drew Trainor, Jack Chen, Jose Schutt-Ainé, and Patrick Chapman, "Development of Three-dimensional Inductors using Plastic Deformation Magnetic Assembly (PDMA)," *IEEE Transactions on Microwave Theory and Techniques*, Vol. 51, No. 4, April 2003.
32. J. Engel, J. Chen, and C. Liu, "Development of Polyimide Flexible Tactile Sensor Skin," *Journal of Micromechanics and Microengineering*, Vol. 13, No. 3, pp. 359-366, May 2003.
33. J. Zou, D. Bullen, X. Wang, C. Liu, and C. Mirkin, "Conductivity-based Contact Sensing for Probe Arrays in Dip-Pen Nanolithography," *Applied Physics Letters*, 2003, Vol. 83, No. 3, July 21, 2003.
34. X. Wang, J. Engel, and C. Liu, "Liquid Crystal Polymer (LCP) for MEMS: Processes and Applications," *Journal of Micromechanics and Microengineering*, Vol. 13, No. 5, pp. 628-633, September 2003.
35. X. Wang, K. Ryu, D. Bullen, J. Zou, H. Zhang, C. Liu, and C. A. Mirkin, "Scanning Probe Contact Printing," *Langmuir*, Vol. 19, No. 21, pp. 8951-8955, October 14, 2003.
36. J. Chen and C. Liu, "Development and Characterization of Surface Micromachined, Out-Of-Plane Hot-Wire Anemometer," *IEEE/ASME Journal of Microelectromechanical Systems*, Vol. 12, No. 6, pp. 979-988, 2003.
37. J. Chen, J. Zou, C. Liu, J. Schutt-aine, S.M. Kang, "Design and modeling of a micromachined high-Q tunable capacitor with large tuning range and a vertical planar inductor," *IEEE Transaction on Electron Devices*, Vol. 50, No. 3, pp. 730-739, March 2003.
38. J. Zou, X. Wang, D. Bullen, K. Ryu, C. Liu, and C. A. Mirkin, "A Mould-and-Transfer Technology for Fabricating Scanning Probe Microscopy (SPM) Probes," *Journal of Micromechanics and Microengineering*, Vol. 14, No. 2, pp. 204-211, February 2004.

39. D. Bullen, X. Wang, J. Zou, S-W Chung, C. A. Mirkin, C. Liu, "Design, Fabrication, and Characterization of Thermally Actuated Probe Arrays for Dip Pen Nanolithography," *IEEE/ASME Journal of Microelectromechanical Systems*, vol. 13, no. 4, pp. 594-602, August 2004.
40. D. Bullen, S.-W. Chung, X. Wang, J. Zou, C. A. Mirkin, and C. Liu, "Parallel dip-pen nanolithography with arrays of individually addressable cantilevers," *Applied Physics Letters*, vol. 84, pp. 789-791, 2004.
41. Z. Fan, J. Engel, J. Chen, and C. Liu, "Parylene Surface Micromachined Membranes for Sensor Applications," *IEEE/ASME Journal of Microelectromechanical Systems*, 13(3), pp. 484-490, 2004.
42. K. Ryu, X. Wang, K. Shaikh and C. Liu, "A Method for Precision Patterning of Silicone Elastomer and Its Applications," *IEEE/ASME Journal of Microelectromechanical Systems*, Vol. 13, No. 4, pp. 568-575, August 2004.
43. K. Ryu, X. Wang, K. Shaikh, D. Bullen, E. Goluch, J. Zou, C. Liu and C. Mirkin, "Integrated Microfluidic Inking Chip for Scanning Probe Nanolithography," *Applied Physics Letters*, vol. 85, no. 1, page 136-138, 5 July 2004.
44. S.J. Park, J.G. Eden, J. Chen, C. Liu, "Microdischarge devices with 10 x 30 micrometer square silicon cathode cavities: pd scaling and production of the XeO excimer", *Applied Physics Letters*, Vol. 85, No. 21, pp. 4869-4871, 2004.
45. Jinghong Chen, Sung-Mo Kang, Jun Zou, Chang Liu, Schutt-Aine, and J.E., "Reduced-order modeling of weakly nonlinear MEMS devices with Taylor-series expansion and Arnoldi approach," *IEEE/ASME Journal of MEMS*, Vol. 13, No. 3, pp. 441-451, 2004.
46. K. Ryu, K. Shaikh, E. Goluch, Z. Fan, C. Liu, "Micro Magnetic Stir-bar Mixer Integrated with Parylene Microfluidic Channels," *The Royal Society of Chemistry (RSC) Journal of Lab on a Chip*, vol. 4, no. 6, pp. 608-613, November 29, 2004.
47. X. Wang, D. Bullen, J. Zou, C. Liu, and C. Mirkin "A Thermally Actuated Probe Array For Parallel Dip Pen Nanolithography," *Journal of Vacuum Science and Technology B*, vol. 22, no. 6, pp. 2563-2567, Nov 2004. (Selected for the Nov. 8, 2004 issue of *Virtual Journal of Nanoscale Science and Technology*, AIP/APS, <http://www.vjnano.org>).
48. E. Goluch, K. Shaikh, K. Ryu, J. Chen, J. Engel, C. Liu, "A Microfluidic Method for In-Situ Deposition and Precision Patterning of Thin-Film Metal on Curved Surfaces," *Applied Physics Letters*, vol. 85, no. 16, pp. 3629-3631, October 18, 2004
49. J. Engel, J. Chen, Z. Fan, and C. Liu, "Polymer Micromachined Multimodal Tactile Sensors," *Sensors and Actuators A: Physical*, vol. 117, no. 1, pp. 50-61, January 3, 2005.
50. Rozhok, Sergey; Kwang-Fu Shen, Clifton; Littler, Pey-Lih Ho; Fan, Zhifang; Liu, Chang; Mirkin, Chad A.; Holz, Richard C. "Methods for Fabricating Microarrays of Motile Bacteria" *Small*, 2005, 1, Volume 1, No. 4, pp. 439-444, January 2005.
51. Sung-Hoon Kim, Jonathan Engel, Chang Liu, and Douglas L. Jones, "Texture classification using a polymer-based MEMS tactile sensor" *Journal of Micromechanics and Microengineering*, 15 (2005) 912-920.
52. Lee, S., Loth, E., and Liu, C. "Micro-bubbles generated on electrolytic arrays and matrices and released in a water channel", *Experiments in Fluids*, Vol. 38, No. 5, pp. 672-682, May 2005.
53. Surya Musunuri, Patrick Chapman, Jun Zou and Chang Liu, "Design Issues for Monolithic DC-DC Converters" *IEEE Transactions on Power Electronics*, vol. 20, no. 3, pp 639-649, May 2005.
54. S. Lee, W. Sutomo, C. Liu and E. Loth, "Micro-fabricated electrolytic micro-bubblers" *International Journal of Multiphase flow*, vol. 31, no. 6, pp 706-722, June 2005.
55. Kashan A. Shaikh, Kee Suk Ryu, Edgar D. Goluch, Jwa-Min Nam, Juewen Liu, C. Shad Thaxton, Thomas N. Chiesl, Annelise E. Barron, Yi Lu, Chad A. Mirkin, Chang Liu, "A Modular Microfluidic Architecture for Integrated Biochemical Analysis," *PNAS*, vol. 102, no. 28, pp. 9745-9750, July 2005.
56. X. Wang, L. Vincent, D. Bullen, J. Zou, and C. Liu, "Scanning Probe Lithography Tips with Spring-on-Tip Designs: Analysis, Fabrication, and Testing", *Applied Physics Letters*, vol. 87, no. 5, p. 054102, Aug 2005 (Selected for the August 8, 2005 issue of *Virtual Journal of Nanoscale Science & Technology*, AIP/APS, <http://www.vjnano.org>)

57. K. Salaita, S. Lee, X. Wang, L. Huang, T. Dellinger, C. Liu, and C. Mirkin, "Sub-100 nm, Centimeter-Scale, Parallel Dip-Pen Nanolithography", *Small*, Vol. 1, No. 10, pp. 940-945, Oct 2005.
58. Xuefeng Wang and Chang Liu, "Multifunctional probe array for nano patterning and imaging," *Nano Letters*, Vol. 5, No. 10, pp. 1867-1872, Oct 2005.
59. D. Bullen and C. Liu, "Electrostatically actuated dip pen nanolithography probe arrays," *Sensors and Actuators A: Physical*, In Press.
60. J. Engel, J. Chen, C. Liu, D. Bullen, "Polyurethane rubber all-polymer artificial hair cell sensor", *IEEE/ASME Journal of MEMS*, Vol. 15, No. 4, pp. 729-736, 2006.
61. Kee Suk Ryu, Kashan Shaikh, Edgar Goluch, and Chang Liu, "A Two-Terminal Longitudinal Hotwire Sensor for Monitoring the Position and Speed of Advancing Liquid Fronts in Microfluidic Channels" *Appl. Phys. Lett.*, accepted.
62. Tim K Hossain, I. Adesida, C. Liu, "Fabrication of suspended micromechanical structures from bulk 6H-SiC using ICP-RIE system", *Journal of Micromechanics and Microengineering*, accepted.
63. Saunvit D Pandya, Yingchen Yang, Douglas Jones, Jonathan M Engel, and Chang Liu, "Multisensor Processing Algorithms for Underwater Dipole Localization and Tracking using MEMS Artificial Lateral Line Sensors" *EURASIP Journal on Applied Signal Processing*, (Special issue on multi sensor processing for signal extraction and applications)
64. Thomas N. Chiesl, Karl. W. Putz, Meena Babu, Patrick Mathias, Kashan A. Shaikh, Edgar D. Goluch, Chang Liu, and Annelise Barron, "Self-associating block copolymer networks for microchip electrophoresis provides enhanced DNA separation via "inchworm" chain dynamics" *Analytical Chemistry*, 78(13), pp. 4406-4415, 2006.
65. Edgar D. Goluch, Jwa-Min Namb, Dimitra G. Georganopoulou, Thomas N. Chiesl, Kashan A. Shaikh, Kee S. Ryua, Annelise E. Barron, Chad Mirkin and Chang Liu, "A Bio-Barcode Assay for On-Chip Attomolar-Sensitivity Protein Detection," *ROC Lab on chip*, accepted.
66. Khalid Salaita, Yuhuang Wang, Joseph Fragala, Rafael A. Vega, Chang Liu, and Chad A. Mirkin, "Massively parallel dip-pen nanolithography with 55,000-pen two dimensional arrays", *Angewandte Chemie*, accepted.
67. Shifeng Li, Kashan Shaikh, Sandra Szegedi, Edgar Goluch, and Chang Liu, "A Micromachined Inking Chip for Scanning Probe Nanolithography Using Local Thermal Vapor Inking Method", *Applied Physics Lett.*, Vol. 89, 2006..
68. Sergey Rozhok, Zhifang Fan, Chang Liu, Chad A. Mirkin, and Richard C. Holz, "Fabrication of motile bacterial cells in a pre-aligned holed microarray," *Langmuir*, accepted.
69. Jonathan Engel, Chang Liu, "Design rules for enhancing strain sensitivity of metal strain gauges on microfabricated polymer structures," *Applied Physics Letters*, accepted.
70. S. Li and C. Liu, "MEMS arrayed scanning probes for soft nanolithography", *Electrochemical Society Transactions*, 3(10), pp. 463-472, 2006.
71. Jonathan Engel, Chang Liu, "Creation of a metallic micromachined chain mail fabric," *Journal of Micromechanics and Microengineering*, in press.
72. Chang Liu, "Micromachined biomimetic artificial haircell sensors", *Journal of Bioinspiration and Biomimetics*, accepted.
73. Nannan Chen, Craig Tucker, Jonathan Engel, Yingchen Yang, Saunvit Pandya, Chang Liu, "Design and Characterization of Artificial Haircell Sensor for Flow Sensing With Ultrahigh Velocity and Angular Sensitivity," *IEEE/ASME Journal of Microelectromechanical Systems*, Vol. 16, No. 5, pp. 999-1014, 2007.
74. S. Peleshank, M. D. Julian, M. Ornatska, M. E. McConney, M. C. LeMieux, N. Chen, C. Tucker, Y. Yang, C. Liu, J. A. C. Humphrey, V. V. Tsukruk, "**Hydrogel-Encapsulated Microfabricated Haircells Mimicking Fish Cupula Neuromast**," ***Advanced Materials*, Vol. 19, No. 19, pp. 2903-2909.**
75. Chang Liu, "Micromachined biomimetic artificial haircell sensors", *Bioinspiration and Biomimetics*, (Bioinspir. Biomim), 2, S162-S169
76. Chang Liu, "recent developments of MEMS", *Advanced Materials*, Vol. 19, No. 22, pp. 3783-3790, 2007.
77. Jonathan Engel, Chang Liu, "Creation of a metallic micromachined chain mail fabric" *Journal of Micromechanics and Microengineering*, Vol. 17, pp. 551-556.

78. Shifeng Li, Timothy M. Dellinger, Qin Wang, Sandra Szegedi, Chang Liu, "Pneumatically actuated elastomeric device for nanoscale surface patterning," *APL*, 91, p. 023109, 2007.
79. Shifeng Li, Sandra Szegedi, Edgar Goluch, Chang Liu, "Dip Pen Nanolithography Functionalized Electrical Gaps for Multiplexed DNA Detection", *Analytical Chemistry*, accepted.
80. Edgar Goluch, Andrew Shaw, Steve Sligar, Chang Liu, "Microfluidic Patterning of Nanodisc Lipid Bilayers and Multiplexed Analysis of Protein Interaction", *LOC*, accepted.
81. Milan Mrksich group collaborative paper.
82. Kashan Shaikh, Chang Liu, "Development of a Latchable Microvalve Employing a Low Melting Temperature Metal Alloy", *Journal of MEMS*, accepted.
83. Yingchen Yang, Douglas Jones, Chang Liu, "Recovery of rectified signals from hot-wire/film anemometers due to flow reversal in oscillating flows", *Review of Scientific Instruments*, 2010 (accepted).
84. Shifeng Li, Edgar Goluch, Chang Liu, Sandra Szegedi, Kashan Shaikh, Faysal Ahmed, Alan Hu, Shenshen Zhao "Gold-Nanoparticle Based Biodetection For Chip-based Portable Diagnosis Systems", *Journal of the Association for Laboratory Automation*, 2010, in press.
85. Edgar D. Goluch, Savka I. Stoeva, Jae-Seung Lee, Kashan A. Shaikh, Chad A. Mirkin, and Chang Liu, "A Microfluidic Detection System Based Upon a Surface Immobilized Biobarcode Assay", *Biosensors and Bioelectronics*, January 2009
86. Shifeng Li, Edgar Goluch, Chang Liu, Sandra Szegedi, Kashan Shaikh, Faysal Ahmed, Alan Hu, Shenshen Zhao "Gold-Nanoparticle Based Biodetection For Chip-based Portable Diagnosis Systems", *Journal of the Association for Laboratory Automation*, 2010, doi: 10.1016/j.jala.2009.11.001.
87. Yingchen Yang, Douglas Jones, Chang Liu, "Recovery of rectified signals from hot-wire/film anemometers due to flow reversal in oscillating flows", *Review of Scientific Instruments*, 2010 81, 015104 (2010); <http://dx.doi.org/10.1063/1.3277109>.
88. Yoon-soo Han, Chang Liu, "Pneumatically Actuated Active Polymer Pen Lithography", *Sensors and Actuators A: Physical*, Volume 167, Issue 2, June 2011, Pages 433–437 doi:10.1016/j.sna.2011.02.029.
89. Nam Nguyen, Douglas L. Jones, Yingchen Yang, and Chang Liu, "Flow Vision for Autonomous Underwater Vehicles via an Artificial Lateral Line," *EURASIP Journal on Advances in Signal Processing*, vol. 2011, Article ID 806406, 11 pages, 2011. doi:10.1155/2011/806406.
90. Yingchen Yang, Adrian Klein, Horst Bleckmann, Chang Liu, "Artificial lateral line canal for hydrodynamic detection", *Applied Physics Letters*, Volume 99, Issue 2, Biophysics and Bio-Inspired Systems, 023701, 2011,
91. Shenshen Zhao, Yuhe Li, Chang Liu, "A tri-axial touch sensor with direct silicon to PC-board packaging", *Sensors and Actuators A:Physical*, Volume 170, Issues 1–2, November 2011, Pages 90–99.
92. Cao Tianyang, Cai, Haoyuan, Fang Dongming, Huang Hui, Liu Chang, " Keyframes Global Map Establishing Method for Robot Localization through Content-Based Image Matching", *Journal of Robotics*, Volume 2017, January 2011.
93. Cao Tianyang, Cai, Haoyuan, Fang Dongming, Liu Chang, "Robot vision system for keyframe global map establishment and robot localization based on graphic content matching", *Guangxue Jingmi Gongcheng/Optics and Precision Engineering*, Volume 25, Issues 8, August 2017, Pages 2221-2232.
94. Cheng Chi, Xuguang Sun, Tong Li, Xin Shu, Ning Xue, Chang Liu, "A Flexible Tactile Sensor With Good Consistency," in *IEEE Access*, vol. 6, pp. 51647-51654, 2018.(SCI: 000446963900001)
95. Xin Shu, Chang Liu, Tong Li, Chunkai Wang, Cheng Chi, "A Self-Supervised Learning Manipulator Grasping Approach Based on Instance Segmentation," in *IEEE Access*, vol. 6, pp. 65055-65064, 2018.(SCI: 000451455300001)
96. Chi Cheng, Sun Xuguang, Xue Ning, Li Tong, Liu Chang. "Recent progress in technologies for tactile sensors". in *Sensors*, vol.18, Issue 4, April 2018.(SCI: 000435574800020)

## Publications in Peer-Reviewed International Conferences

1. C. Liu, T. Tsao, Y.C. Tai, and C.M. Ho, "Surface Micro-machined Magnetic Actuators," Proceedings, *IEEE Workshop on Micro-Electro-Mechanical-Systems*, MEMS'94, Oiso, Japan, pp. 57-62, 1994.
2. C. Liu and Y.C. Tai, "Studies on the Sealing of Surface Micro-machined Cavities by Using Chemical Vapor Deposition Methods," *5th IEEE Solid-State Sensor and Actuator Workshop*, Hilton Head Island, SC, pp. 103-106, 1994.
3. C. Liu, Y.C. Tai, J.B. Huang, and C.M. Ho, "Surface Micro-machined Thermal Shear-Stress Sensor," *First ASME Symposium on Application of Micro-Fabrication to Fluid Mechanics*, Chicago, IL, pp. 9-15, November 1994.
4. T. Tsao, C. Liu, Y.C. Tai, and C.M. Ho, "Micro Magnetic Actuators for Active Fluid Control," *First ASME Symposium on Application of Micro-Fabrication to Fluid Mechanics*, Chicago, IL, pp. 31-38, 1994.
5. C. Liu, T. Tsao, Y.C. Tai, J. Leu, C.M. Ho, W.L. Tang, and D.K. Miu, "Out-Of-Plane Permalloy Magnetic Actuators," *IEEE Workshop on Micro-Electro-Mechanical Systems*, MEMS '95, the Netherlands, pp. 7-12, 1995.
6. C. Liu, T. Tsao, P. Will, Y.C. Tai, and W.H. Liu, "A Micromachined Permalloy Magnetic Actuator Array for Micro Robotics Assembly Systems," *Proceedings of the 1995 International Conference on Solid-State Sensors and Actuators*, Transducer '95, Sweden, 1995.
7. G.B. Lee, C.M. Ho, F.K. Jiang, C. Liu, T. Tsao, and Y.C. Tai, "Distributed Flow Control by MEMS," *ASME Annual Meeting*, 1996.
8. C. Liu, T. Tsao, and Y.C. Tai, "A High Yield Drying/Release Process for Surface Micromachined Polysilicon Structures," *1997 Int. Conf. on Solid-state Sensors and Actuators (Transducers'97)*, Chicago, IL, pp. 241-244, June 1997.
9. I. Vasic, C. Liu, F. A. Khan, M. A. Shannon, and M. Q. Brewster, "HTPB Melt Layer Viscosity Using Plate Wave Microsensors," *33rd JANNAF Combustion Meeting*, Monterey, CA, 4-7 November 1996.
10. C. Liu, M. A. Shannon, and I. Adesida, "Side Wall Definition for Through-wafer Interconnects using 45 degree Mirror Surfaces," *Late News Session Supplemental Digest, IEEE Solid State Sensor and Actuator Workshop*, Hilton Head, SC, pp. 25-26, 1996.
11. C. Liu, "Integration of a MEMS education curriculum with interdisciplinary research," *12th University/Government/Industry microelectronics symposium*, pp. 137-141, 1997.
12. C. Liu, T. Tsao, and Y.C. Tai, "A High Yield Drying/Release Process for Surface Micromachined Polysilicon Structures," *Int. Conf. on Solid-state Sensors and Actuators*, Transducer'97, Chicago, pp. 241-244, IL, June 1997.
13. Liu, "Through-wafer electrical interconnects by sidewall photo-lithography patterning," *International Measurement Technology Conference*, St. Paul, MN, pp. 1402-1405, May, 1998.
14. C. Liu, "Silicon micromachined magnetic actuators for interaction with strong and dynamic air flow," *U.S. National Congress of Applied Mechanics*, Florida, USA, June 1998.
15. Y. Yi and C. Liu, "Mechanically stable micro assembly using magnetostatic actuation", *Int. Conf. on Solid-state IC Technology, ICSICT 98*, Beijing, Oct 1998. (Winner, Conference Best Paper Award sponsored by the *Applied Materials Inc.*)
16. Y. Yi and C. Liu, "Parallel assembly of hinged microstructures using magnetic actuation," *IEEE solid-state sensors and actuators workshop*, Hilton Head Island, SC, pp.269-272, 1998.
17. Z. Zhu and C. Liu, "Anisotropic Crystalline Etching Simulation using a Continuous Cellular Automata Algorithm," *ASME Symposium on Computer Aided Simulation of MEMS*, Anaheim, CA, Nov 1998.
18. Y. Yi and C. Liu, "High-Yield Assembly of Hinged 3D Optical MEMS Devices Using Magnetic Actuation", *SPIE Micromachining and Microfabrication Symposium*, Santa Clara, CA, Sep 1998.
19. Jun Zou, Colin Byrne, Chang Liu, and David Brady, "Optical Properties of Micromachined Polysilicon Reflective Surfaces with Etching Holes", *SPIE Micromachining and Microfabrication Symposium*, Santa Clara, CA, Sep 1998.

20. B. Choi, M. Ma, C. White, and C. Liu, "Electrolytic and thermal bubble generation using AC inductive powering," *1999 International Conference on Solid-State Sensors and Actuators, Transducers'99*, Sendai, Japan, 1999.
21. Y. Yi and C. Liu, "Parallel assembly of micro optical components", *1999 International Conference on Solid-State Sensors and Actuators, Transducers'99*, Sendai, Japan, 1999.
22. D. Armani and C. Liu, "Re-configurable Fluid Circuits By PDMS Elastomer Micromachining", *12th International Conference on MEMS, MEMS 99*, pp.222-227, Orland, FL, 1999.
23. G. Barbastathis, M. Balberg, D. J. Brady, B. Choi, and C. Liu, "Holographic 3D imaging of microstructures," *SPIE: The international symposium on optical science, engineering and instrumentation*, Denver, Colorado, pp. 3801-23, July 1999.
24. J. Bernhard, N.W. Chen, R. Clark, M. Feng, C. Liu, P. Mayes, and E. Michielssen, "Mechanically conformal and electronically reconfigurable apertures using low voltage MEMS and flexible membranes for space based radar applications," *2000 IEEE AP-S (Antenna Propagation) International Symposium*, Salt Lake City, Utah, July 16-21, 2000.
25. J. Zou and C. Liu, "Development of a novel micro electromechanical tunable capacitor with a high tuning range", *58th Device Research Conference (DRC)*, June 19-21, Denver, CO, pp. 111-112, 2000.
26. M. Khoo and C. Liu, "Development of A Novel Micromachined Magnetostatic Membrane Actuator", *58th Annual IEEE Device Research Conference*, pp. 109-110, Denver, CO, 2000.
27. D. Armani and C. Liu, "Microfabrication Technology for Polycaprolactone, A Biodegradable Polymer" *Int. Conf. on MEMS, MEMS 2000*, Japan.
28. Melvin Khoo and C. Liu, "A Novel Micromachined Magnetic Membrane Microfluid Pump", *22nd Annual International Conference of the IEEE Engineering in Medicine and Biology Society*, Chicago, IL, 2000.
29. Junjun Li, Jack Chen, and C. Liu, "Micromachined Biomimetic Sensor Using Modular Artificial Hair Cells", *NASA NanoSpace*, Houston, TX, 2000.
30. X. Wang and C. Liu, "Development of microfabrication techniques for liquid crystal polymer", *Proc. Int. Conf. On MEMS (MEMS 01)*, Interlaken, Switzerland, January, 2000.
31. J. Zou, C. Liu, J. Schutt-Aine, J. Chen, and S.M. Kang, "Development of a Wide Tuning Range MEMS Tunable Capacitor for Wireless Communication Systems", *International Electron Devices Meeting (IEDM)*, San Francisco, 2000.
32. J. Zou, J.G. Nickel, D. Trainor, C. Liu, and J.E. Schutte-Aine, "Development of Vertical Planar Coil Inductors Using Plastic Deformation Magnetic Assembly (PDMA)," *2001 IEEE International Microwave Symposium*, Phoenix, 20-25 May 2001.
33. Liang-Hsuan Lu, X. Wang, and C. Liu, "An efficient low-cost micro fabrication method of capillary electrophoresis chip using liquid crystal polymer (LCP)", L1006, *14th Int. Symp. on Microscale Separations and Analysis*, Jan 13-18, Boston, MA, 2001.
34. J. Zou, J. Chen, and C. Liu, "Plastic Deformation Magnetic Assembly (PDMA) of 3-D Microstructures: Technology Development and Application," *2001 Int. Conf. on Solid-state Sensors and Actuators, Transducers 01*, Paper 4C2.04, Munich, Germany, June 2001.
35. J. Chen, S.J. Park, J.G. Eden, and C. Liu, "Microdischarge Device Fabricated in Silicon by Micromachining Technique with Pyramidal Cavity," *2001 Int. Conf. on Solid-state Sensors and Actuators, Transducers 01*, Paper 2C1.05P, Munich, Germany, 2001.
36. S.J. Park, J. Chen, C. Liu, and J.G. Eden, "Microcavity Plasma Discharge Arrays For Display Applications," *Symposium Information Display 2001 (SID 2001)*, pp. 775-777, June 2001.
37. S.J. Park, J. Chen, C. Liu, J.G. Eden, "Large scale microdischarge arrays: fabrication and characterization," *CLEO, Optical Society of America*, 2001.
38. J. Li, Z. Fan, J. Chen, J. Zou, C. Liu, and F. Delcomyn, "High yield microfabrication process for biomimetic artificial haircell sensors", Smart Electronics, MEMS, and Nanotechnology Conference (Conference 4700), *SPIE 9th Annual International Symposium on Smart Structures and Materials*, 17-21 March 2002, San Diego, CA.
39. D. Bullen, M. Zhang, and C. Liu, "Thermal-Mechanical Optimization of Thermally Actuated Cantilever Beam Array," Smart Electronics, MEMS, and Nanotechnology Conference (4700),

- SPIE 9th Annual International Symposium on Smart Structures and Materials*, 17-21 March 2002, San Diego, CA.
40. Xu, F. Delcomyn and C. Liu, "Micromachined metal neuron probes," *Society of Neuron Sciences, Annual Conference*, 2001.
  41. L-H Lu, K. Ryu, and C. Liu, "A Novel Microstirrer and Arrays for Microfluidic Mixing," *Fifth International Conference on Miniaturized Chemical and Biochemical Analysis Systems (μTas 2001)*, Oct 21-25, 2001.
  42. S. Hong, S. Chung, C. Mirkin, M. Zhang, D. Bullen, and C. Liu, "Dip Pen Nanolithography MEMS Nanoplotter - A new tool capable of massive parallel patterning via passive and active probes," *Gordon Research Conference: Clusters, Nanoparticles, and Nanocrystals*, July 29-Aug 3, 2001.
  43. M. Zhang, D. Bullen, K. Ryu, C. Liu, S. Hong, S. Chung, and C. Mirkin "Passive and Active Probes for Dip Pen Nanolithography," *Proc. First IEEE Int. Conference on Nanotechnology*, Maui, HI, October 28-30, 2001.
  44. Z. Fan, J. Li, J. Chen, J. Zou, and C. Liu, "Development of artificial lateral line underwater flow sensors," *Solid-state Sensor, Actuator, and Microsystems Workshop*, Hilton Head Island, June 2002.
  45. J. Chen, J. Zou, and C. Liu, "A Micromachined, Out-of-Plane Anemometer," *Proceedings of IEEE Int. Conf. MEMS*, (MEMS 02), Las Vegas, NV, 2002.
  46. X. Wang, J. Engel, J. Chen, and C. Liu, "Liquid Crystal Polymer Based MEMS Applications", 4<sup>th</sup> Advanced Technology Workshop on Packaging of MEMS and Related Micro Integrated Nano Systems, International Microelectronics And Packaging Society Symposium (IMAPS 2002), Denver, CO, September 4-6, 2002.
  47. C. Liu, J. Chen, J. Zou, and Z. Fan, "Three Dimensional PDMA Assembly: Design, Process and Applications," The MEMS Symposium, 2002 International Mechanical Engineering Congress (IMECE 2002), New Orleans, LA, Nov. 17-22, 2002.
  48. C. Liu, J. Zou, J. Chen, Z. Fan, and Fred Delcomyn, "Plastic Deformation Magnetic Assembly Method and Its Applications," 7th Symposium on Magnetic Materials, Processes and Devices, SESSION LL4: NANOSCALE RAPID PROTOTYPING, 202nd Electrochemical Society Meeting, Salt Lake City, UT, Oct 20-25, 2002.
  49. D. Bullen, S. Chung, X. Wang, J. Zou, C. Liu, and Chad Mirkin, "Development of parallel dip pen nanolithography probe arrays for high throughput nanolithography," Symposium LL: Rapid Prototyping Technologies, Materials Research Society (MRS) Fall annual meeting, Boston, MA, December 2002.
  50. Kee Ryu, Chang Liu, "Precision Patterning of PDMS Thin Films: A New Fabrication Method and Its Applications," Sixth International Symposium on Micro Total Analysis System (mTAS), November 3-7, Nara, Japan, 2003.
  51. Kee Ryu, Zhi Fan, and Chang Liu, "Microfabrication Process for High-density Micro Pipette Array and Matching Multi-Well Plate with Mixers," Sixth International Symposium on Micro Total Analysis System (mTAS), November 3-7, Nara, Japan, 2003.
  52. Xuefeng Wang, David Bullen, Jun Zou, Kee Ryu and Chang Liu, Sung-Wook Chung, and Chad Mirkin, "Linear Probe Arrays for Dip-Pen Nanolithography," International Conference on Micro & Nano Systems (IMAPS 2002), August 11-14, 2002, Kunming, China.
  53. W. Sutomo, X. Wang, D. Bullen, S. K. Braden, J. Chen, C. Liu, "An In-situ End-Point Detector for Parylene CVD Deposition," 16th Int. Conf. on MEMS, MEMS 2003, Kyoto, Japan, January 2003.
  54. D. Bullen, X. Wang, J. Zou, S. Hong, S.-W. Chung, K. S. Ryu, Z. Fan, C. A. Mirkin, C. Liu, "Micromachined Arrayed Dip Pen Nanolithography (DPN) Probes for Sub-100 nm Direct Chemistry Patterning," 16th Int. Conf. on MEMS, MEMS 2003, Kyoto, Japan, January 2003.
  55. J. Engel, C. Liu, B. R. Flachsbar, J. C. Selby, M. A. Shannon, "Development of polyimide-based flexible tactile sensing skin," Materials Research Society Fall Meeting, SESSION D4: ELECTRONICS ON FLEXIBLE SUBSTRATES, Boston, MA, 2-6 December 2002.



56. S. Lee, W. Sutomo, C. Liu, and E. Loth, "MEMS-based electrolytic microbubbler in a water tunnel," Proceedings of 2003 Fluids Engineering Division Summer Meeting, Symposium on Microbubble and Polymer Friction Drag Reduction, July 6-10, 2003, Honolulu, Hawaii.
57. J. Engel, J. Chen, and C. Liu, "Development of a Multi-Modal, Flexible Tactile Sensing Skin Using Polymer Micromachining," The 12th International Conference on Solid-State Sensors, Actuators and Microsystems, Boston, MA, 2003.
58. J. Chen, J. Engel, and C. Liu, "Development of Polymer-Based Artificial Haircell Using Surface Micromachining and 3D Assembly," The 12th International Conference on Solid-State Sensors, Actuators and Microsystems, Boston, MA, 2003.
59. X. Wang, K. Ryu, and C. Liu, "Scanning Probe with Elastomeric (PDMS) Tip for Tip-Based Microcontact Printing," The 12th International Conference on Solid-State Sensors, Actuators and Microsystems, Boston, MA, 2003.
60. S. Lee, W. Sutomo, C. Liu, and E. Loth, "*MEMS-based electrolytic microbubbler in a water tunnel*," Proceedings of 2003 Fluids Engineering Division Summer Meeting, Symposium on Microbubble and Polymer Friction Drag Reduction, Honolulu, Hawaii, 6-10 July 2003.
61. J. Engel, J. Chen, X. Wang, Z. Fan, C. Liu, and D. Jones, "*Technology Development of Integrated Multi-modal and Flexible Tactile Skin for Robotics Applications*," IEEE/RSJ International Conference on Intelligent Robots and Systems, Las Vegas, NV, 2003.
62. J. Chen, Z. Fan, J. Engel, and C. Liu, "Towards Modular Integrated Sensors: The Development of Artificial Haircell Sensors Using Efficient Fabrication Methods," IEEE/RSJ International Conference on Intelligent Robots and Systems (IROS 2003), Las Vegas, Nevada, Vol. 3, pp. 2341-2346, 27-31 October 2003.
63. K. S. Ryu, K. Shaikh, and C. Liu, "Micro Magnetic Stir-bars Integrated In Parylene Surface-micromachined Channels For Mixing and Pumping," presented at The Seventh International Conference on Miniaturized Chemical and Biochemical Analysis Systems (microTAS 2003), Squaw Valley, California USA, 2003.
64. K. S. Ryu, K. Shaikh, and C. Liu, "A Method To Monolithically Integrate Elastomer O-rings on Parylene Membranes For Improved Valve Sealing," presented at The Seventh International Conference on Miniaturized Chemical and Biochemical Analysis Systems (microTAS 2003), Squaw Valley, California USA, 2003.
65. K. Shaikh, K. S. Ryu, Z. Fan, and C. Liu, "Fabrication of Through-wafer Fluid Interconnects with Low Dead Volume and Integrated Back-Plane Fluid Jumpers," presented at The Seventh International Conference on Miniaturized Chemical and Biochemical Analysis Systems (microTAS 2003), Squaw Valley, California USA, 2003.
66. J. Chen, Z. Fan, J. Engel, and C. Liu, "Towards Modular Integrated Sensors: The Development of Artificial Haircell Sensors Using Efficient Fabrication Methods," presented at IEEE/RSJ International Conference on Intelligent Robots and Systems, Las Vegas, NV, 2003.
67. K. Ryu, X. Wang, K. Shaikh, E. Goluch, D. Bullen, J. Zou, C. Liu, "An Integrated Microfluidic Inking Chip for SPM Nanolithography," The 11th Solid State Sensor, Actuator, and Microsystems Workshop (Hilton Head 2004), Hilton Head Island, SC, 6-10 June 2004.
68. C. Liu, J. Chen, J. Engel, and Z. Fan, "Biomimetic micro sensors based on polymer micromachining," presented at The 227th National Meeting of the American Chemical Society (ACS), Anaheim, CA, 2004.
69. X. Wang, L. Vincent, M. Yu, Y. Huang, and C. Liu, "A Thermally Actuated Three-Probe Nanomanipulator For Efficient Handling of Individual Nanostructures," 17th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2004, Maastricht, Netherlands, pp. 442-445, 25-29 January 2004.
70. K. Ryu, X. Wang, K. Shaikh, E. Goluch, D. Bullen, J. Zou, C. Liu, "An Integrated Microfluidic Inking Chip for SPM Nanolithography," The 11th Solid State Sensor, Actuator, and Microsystems Workshop (Hilton Head 2004), Hilton Head Island, SC, 6-10 June 2004.
71. C. Liu, J. Chen, J. Engel, and Z. Fan, "Biomimetic micro sensors based on polymer micromachining," presented at The 227th National Meeting of the American Chemical Society (ACS), Anaheim, CA, 2004.

72. J. Chen, J. Engel, M. Chang, and C. Liu, "3D out of plane flow sensor array with integrated circuits," Eurosensors, XVI, Rome, 2004.
73. C. Liu, "Micro machined tools for nano patterning," 2004 Gordon Research Conference on Nanostructure fabrication, Tilton, NH July 18-23, 2004.
74. J. Engel, Z. Fan, L. Zhao, J. Chen, and C. Liu, "Smart brick – a low cost, modular wireless sensor for civil structure monitoring," International Conference on Computing, Communications, and Control technologies, (CCCT 2004), Austin, TX, August 14-17, 2004.
75. X. Wang, L. Vincent, M. Yu, Y. Huang, and C. Liu, "A Thermally Actuated Three-Probe Nanomanipulator For Efficient Handling of Individual Nanostructures," 17th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2004, Maastricht, Netherlands, pp. 442-445, 25-29 January 2004.
76. Kashan Shaikh, Kee Ryu, Edgar Goluch, Patrick Mathias, Chang Liu, "Technology Development for Automated, Portable Lab-on-Chip for Early Cancer Detection", Gordon Conference on New Frontiers for Early Cancer Detection, January 17-21, Santa Ynez, CA, 2005.
77. J. Engel, J. Chen, D. Bullen, and C. Liu, "Polyurethane Rubber as a MEMS Material: Characterization and Demonstration of an All-Polymer Two-Axis Artificial Haircell Flow Sensor," 18th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2005, Miami Beach, FL USA, January 2005.
78. J. Chen, J. Engel, N. Chen, and C. Liu, "A Monolithic Integrated Array of Out-of-Plane Hot-Wire Flow Sensors and Demonstration of Boundary-Layer Flow Imaging," 18th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2005, Miami Beach, FL USA, January 2005.
79. E. Goluch, J.-M. Nam, T. Chiesl, K. Shaikh, K. Ryu, A. Barron, C. Mirkin, C. Liu, "A Microfluidic Chip for Bio-Bar-Code-Based Detection of Proteins," The American Institute of Chemical Engineers (AIChE) 2004 Annual Meeting, Austin, TX USA, November 7-12, 2004.
80. E. Goluch, K. Shaikh, K. Ryu, J. Chen, J. Engel, C. Liu, "A Microfluidic Method for Sensor Fabrication on Curved Surfaces," The American Institute of Chemical Engineers (AIChE) 2004 Annual Meeting, Austin, TX USA, November 7-12, 2004.
81. C. Liu, "Microfluid chip for cancer detection," poster presentation at the Gordon Conference on New Frontiers in Cancer Detection and Diagnosis, Santa Ynez, CA, January 16-21, 2005.
82. J. Chen, J. Engel, N. Chen, and C. Liu, "A Monolithic Integrated Array of Out-of-Plane Hot-Wire Flow Sensors and Demonstration of Boundary-Layer Flow Imaging," 18th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2005, Miami Beach, FL USA, January 2005
83. J. Engel, J. Chen, D. Bullen, and C. Liu, "Polyurethane Rubber as a MEMS Material: Characterization and Demonstration of an All-Polymer Two-Axis Artificial Haircell Flow Sensor," 18th IEEE International Conference on Micro Electro Mechanical Systems, MEMS 2005, Miami Beach, FL USA, January 2005.
84. Chang Liu, "Progress in MEMS and Micro Systems Research," IMAPS/ACerS 1st International Conference and Exhibition on Ceramic Interconnect and Ceramic Microsystems Technologies (CICMT), Baltimore Marriott Waterfront Hotel, Baltimore, MD, USA, April 10-13, 2005.
85. Xuefeng (Danny) Wang, Jun Zou, David Bullen, Timothy Dellinger, Kee Ryu and Chang Liu, "MEMS for Nanotechnology Applications - Nanopatterning and Nanomanipulation," China International Conference on Nanoscience & Technology (ChinaNANO2005), Beijing, China, June 9-11, 2005.
86. K. Ryu, K. Shaikh, E. Goluch, P. Mathias, and C. Liu, "A Simple Two Terminal Longitudinal Hotwire Sensor for Monitoring the Position and Speed of Advancing Liquid Fronts In Micro Channels," The Ninth International Conference on Miniaturized Systems for Chemistry and Life Sciences (microTAS 2005), Boston, Massachusetts, 9-13 Oct 2005, accepted
87. K. Ryu, X. Wang, K. Shaikh, E. Goluch, P. Mathias, and C. Liu, "Design And Prototyping Of A Surface Micromachined Parylene Microvalve with Hybrid Actuation Scheme: On-Chip Thermopneumatic Initiation and Electrostatic Latching," The Ninth International Conference on Miniaturized Systems for Chemistry and Life Sciences (microTAS 2005), Boston, Massachusetts, 9-13 Oct 2005, accepted

88. E. Goluch, K. Shaikh, K. Ryu, J. Chen, J. Engel, and C. Liu, "Deposition and Patterning of Thin-Film Materials on Curved Surfaces using Microfluidic Methods," The Ninth International Conference on Miniaturized Systems for Chemistry and Life Sciences (microTAS 2005), Boston, Massachusetts, 9-13 Oct 2005, accepted
89. E. Goluch, D. Georganopoulou, S. Stoeva, J.-M. Nam, K. Shaikh, K. Ryu, T. Chiesl, A. Barron, C. Mirkin and C. Liu, "Optimization of a Microfluidic Chip for the Biobarcode Assay," The Ninth International Conference on Miniaturized Systems for Chemistry and Life Sciences (microTAS 2005), Boston, Massachusetts, 9-13 Oct 2005, accepted
90. E. Goluch, D. Georganopoulou, S. Stoeva, J.-M. Nam, K. Shaikh, K. Ryu, T. Chiesl, A. Barron, C. Mirkin and C. Liu, "Development and Optimization of a Lab-on-a-chip Device for Multiplexed Ultra-Sensitive Detection of Proteins," The American Institute of Chemical Engineers (AIChE) 2005 Annual Meeting, Cincinnati, OH USA, October 30-November 4, 2005
91. K. Ryu, K. Shaikh, E. Goluch, P. Mathias, and C. Liu, "Two-Terminal Longitudinal Hotwire Sensor for In-Line Monitoring of Sub-Nanoliter Volume in Microfluidic Channels," The 4th IEEE International Conference on Sensors, Irvine, California, 31 Oct- 1 Nov, 2005, accepted
92. Saunvit Pandya, Jonathan Engel, Jack Chen, Zhifang Fan, and Chang Liu, "CORAL: Miniature Acoustic Communication Subsystem Architecture for Underwater Wireless Sensor Networks," The 4th IEEE International Conference on Sensors, Irvine, California, 31 Oct- 1 Nov, 2005, accepted
93. Nannan Chen, Jonathan Engel, Jack Chen, Zhifang Fan, Chang Liu, "Micromachined Thermal Imaging Mesh for Conformal Sensing System," The 4th IEEE International Conference on Sensors, Irvine, California, 31 Oct- 1 Nov, 2005, accepted
94. Jonathan Engel, Jack Chen, Nannan Chen, Chang Liu, "Development and Characterization of an Artificial Hair Cell Based on Polyurethane Elastomer and Force Sensitive Resistors," The 4th IEEE International Conference on Sensors, Irvine, California, 31 Oct- 1 Nov, 2005, accepted.
95. Jonathan Engel, Jack Chen, Nannan Chen, Saunvit Pandya, Chang Liu, "Multi-Walled Carbon Nanotube Filled Conductive Elastomers: Materials and Application to Micro Transducers," MEMS 2006 Conference, Istanbul, Turkey, January 22 - 26, 2006, accepted
96. Jack Chen, Jonathan Engel, Nannan Chen, Saunvit Pandya, Sheryl Coombs, and Chang Liu, "Artificial Lateral Line and Hydrodynamic Object Tracking," MEMS 2006 Conference, Istanbul, Turkey, January 22 - 26, 2006, accepted
97. N. Chen, J. Engel, S. Pandya, and C. Liu, "Flexible Skin With Twoaxis Bending Capability Made Using Weavingbylithography Fabrication Method," MEMS 2006 Conference, Istanbul, Turkey, January 22 - 26, 2006, accepted.
98. Huan Hu, Shenshen Zhao, and Chang Liu "Comprehensive characterization of contact, bulk and total resistance of strain-sensitive nanocomposite elastomer", The 23rd IEEE International Conference on Micro Electro Mechanical Systems, Hong Kong, China, January 24-28, 2010, accepted
99. Cao Tianyang, Cai, Haoyuan, Fang Dongming, Liu Chang, "An innovation indoor robot self-localization system with fast vision content matching in global map", ICNC-FSKD 2017 - 13th International Conference on Natural Computation, Fuzzy Systems and Knowledge Discovery, June 2018, Pages 745-752.
100. Chi C, Sun X, Li T, et al. Preparation of multi-walled carbon nanotubes/polydimethylsiloxane composite for electronic skin application[C]//2018 IEEE 8th International Nanoelectronics Conferences (INEC). IEEE, 2018: 41-42.
101. Li T, Chi C, Wang C, et al. Real-Time and Autonomous Grasping Operation of Manipulator Based on Tactile Sensor Array[C]//2018 2nd IEEE Advanced Information Management, Communicates, Electronic and Automation Control Conference (IMCEC). IEEE, 2018: 732-736.
102. Shu Xin, Liu Chang, Cai Haoyuan, Cao, Tianyang. Design of Indoor Real-time Positioning on Embedded Platform. [C]// 2nd International Conference on Mechanical, Electronic, Control and Automation Engineering (MECAE). 2018, 331-336
103. Shu Xin, Liu Chang, Li Tong. Manipulator Grasping Based on Object Detection.[C]//2018 International Conference on Transportation & Logistics, Information & Communication, Smart City (TLICSC 2018). Atlantis Press, 2018, 1951-6851.

## Software

Zhu and C. Liu, software titled “Anisotropic Crystalline Etching Simulation (ACES) software”. This free-ware software title is available on-line at <http://galaxy.micro.uiuc.edu/research/completed/aces/index.html>. It has been downloaded more than by more than 1000 distinct users from academia, industry, and military since it was published in 1998.

The MASS Group has recently developed modular microfluidic architecture for building custom lab-on-a-chip systems.

## Invited Talks

1. IIT ECE Distinguished Speaker Seminar Series, Illinois Institute of Technology, December 2000.
2. Invited seminar titled "Application of Micro Electromechanical Systems (MEMS) to Biological and Medical Research," Northern Illinois University, Department of Biological Sciences.
3. C. Liu, "A magnetic flexible membrane actuator for micro fluid pumping (Invited)", Sixth International Symposium on Magnetic Materials, Processes and Devices, a Symposium at the 198th Meeting of the Electrochemical Society, Oct 22-27, 2000, Phoenix, Arizona.
4. Invited talk, “Magnetic MEMS for RF communications, sensors and microfluidics”, NSF Education/Research Center for Wireless Integrated Microsystems, University of Michigan, Ann Arbor, MI, October 9, 2001.
5. Invited Seminar, "Underwater Biomimetic Sensors", MIT Sea Grant Program and the Ocean Engineering Department, Cambridge, MA, February 19, 2002.
6. Invited speaker, “Case Studies for Micro Electromechanical Systems”, 2002 Summer School on Computational Material Science titled “Computational approaches for simulation of electron devices and MEMS”, Champaign, IL, May 21-28, 2002.
7. Invited seminar speaker, “Micromachined tweezers for micro and nanoscale manipulations”, International Conference on Robotics and Automation (ICRA), Washington D.C., May 12, 2002.
8. Invited short course, “Applications of MEMS in Fluid Mechanics and Aerospace Industry,” AEROMEMS workshop, the Ministry of Education, Taipei, Taiwan, 2002.
9. Invited talk, “MEMS for Certain Nanotechnology Applications (M4N)“, Chemistry Division, Argonne National Laboratory, July 17, 2003.
10. Invited talk, “Polymer micromachining and applications in sensors, microfluidics, and nanotechnology “, American Chemistry Society Annual Meeting, New York City, NY, Sept 7, 2003.
11. Invited talk, “Micro Integrated Sensors Research at the University of Illinois”, Sensors Expo, Anaheim, CA, (Invited by James Wiczer, Sensor Synergy Co.) September 23, 2003.
12. Invited talk, “MEMS Smart Skin for Tactile and Flow Sensing”, BioEngineering Department, University of California at Irvine, September 24, 2003.
13. Invited talk, “MEMS Smart Skin for Tactile and Flow Sensing”, EE Department, Caltech, Pasadena, CA, September 24, 2003.
14. Invited talk, Ceramics Seminar, “Materials and Fabrication Issues of Micromachining and MEMS”, Material Science and Engineering Department, University of Illinois at Urbana-Champaign, Urbana, IL, October 9, 2003.
15. Invited talk, “Sensitive Multimodal Skin as a Sensor Network”, Computer Systems Laboratory Seminar, University of Illinois, October 2003.
16. Invited talk, “MEMS Applications in Sensors, Microfluidics, and Nanotechnology “, Global Research Center, GE Corporation, November 11, Albany, NY, 2003.
17. Frontier of Nanotechnology Seminar, “Microengineering for nanotechnology,” Institute for Nanotechnology, Northwestern University, May 26, 2004.
18. Gordon Conference on Nanostructures Manufacturing, “MEMS tools for nanolithography,” Tilton School, NH, July 2004.

19. Joint NSF/DARPA Workshop on Direct Write Technologies, June 27-July 1, 2004.
20. Invited speaker, "MEMS research at the interface of sensors, nanotech, and microfluidics", Intel Research, Santa Clara, CA, September 2, 2004.
21. Invited speaker, "Microfabrication technology," Mechanical Engineering, Stanford University, Palo Alto, CA, September 3, 2004.
22. Invited speaker, "Micromachining Technology for Nanolithography, Sensors, and Microfluidics," IBM Almaden Research Center, San Jose, CA, September 4, 2004.
23. Invited talk, "Three dimensional assembly microfabrication process and applications in sensors," Seoul National University, January 6, 2005.
24. Invited shortcourse, "Polymer sensors for bio and robotics applications," Seoul National University, January 7, 2005.
25. Invited talk, "Smart Brick Technology for Building and Construction Industry", MPCX conference (Trade Association of Ceramics and Concrets), Indianapolis, February 11, 2005
26. Invited talk, "MEMS research on sensors and microfluidics", Webster Center for Science and Technology (WCST), Xerox Corporation, March 03, 2005. Host: Charles Duke, VP and Senior Fellow of Xerox
27. Invited talk, "Advanced Nano Lithography Tools Based on MEMS Technology", MANTL Nanotechnology Workshop, May 5, 6, 2005
28. Invited talk, "Progress in MEMS and Micro Systems Research," 1st AcerS/IMPAS (American Ceramics Society) International Conference and Exhibition on Ceramic Interconnect and Ceramic Microsystems Technology (CICMT), Baltimore Marriott Waterfront Hotel, Baltimore, MD, USA, April 11-13
29. Invited talk, "MEMS for nanotechnology applications – nanopatterning and nanomanipulation," China International Conference on Nanoscience and Technology (ChinaNano2005), Beijing International Convention Center, Beijing, China, June 9-11, 2005
30. Invited talk, "Biomimetic artificial haircell sensors for sensor skin applications," Institute for Cell Mimetic Space Exploration, UCLA, April 26, 2005
31. Invited talk, "Advanced nanolithography tools based on MEMS technology", MNTL/CNST Nanotechnology Workshop, May 5-6, 2005, Urbana, IL
32. Invited talk, "Hybrid Polymer Microfabrication and Applications in Sensors and Nanotechnology", Nano Seminar, Mechanical Engineering, University of California at Berkeley, May 12, 2005
33. Invited talk, "Artificial Haircell Sensors and Sensor Skin Based on Biological Inspirations" International Conference on Bio-Nano-Information Fusion, Marina del Rey, CA, USA, July 20-22, 2005
34. Invited talk, Physics Colloquium, "Polymer-MEMS Applications in Nanotechnology and Sensors", IUPUI (Indiana University Purdue University Indianapolis), Sept 22, 2005.
35. Invited talk, 9th Nano Engineering and Micro Systems Technology Conference, "Polymer MEMS applications in Nanotechnology, Biodetection, and Sensors", Tainan, Taiwan, November 11, 2005.
36. Invited talk, "Hybrid Polymer Microfabrication and Applications in Sensors and Nanotechnology" Boeing Company Distinguished Researcher and Scholar Seminar, Huntington Beach, California, Nov. 1, 2005.
37. Invited talk, "Artificial haircell sensors: development and applications", Center for Solid-State Electronics Research, Arizona State University, January 23, 2006.
38. Invited talk, "Biologically Inspired Sensors – a new face of sensing", GE Global Research Center, New York, February 10, 2006.
39. Invited talk, "Overview of Research at the Micro And Nano Science and Systems Group", US Army Construction Engineering Research Laboratory, April 19, 2006.
40. Invited planetary speaker, Biomimetic Artificial Haircell Sensors: Designs, Materials, and Applications, the 3<sup>rd</sup> International Workshop on Advanced Smart Materials and Smart Structures Technology, Lake Tahoe, NV, May 29-30, 2006.
41. Invited talk, Multifunctional Probe and Local Vapor Inking Chip for Scanning Probe Nanolithography, IEEE Nano 2007, Cincinnati, OH, July 18, 2006.

42. Invited talk, Engineering across nano-micro-macro scales for applications in bioinspired sensing, Berkeley Sensors and Actuators Center, August 7, 2006.
43. Invited session chair, "Seeing at the nanoscale V conference", June 24-27, Santa Barbara, CA, 2006.
44. Invited plenary talk, "Bioinspired Sensors," Eurosensors 2008, Germany, September 2008.
45. Chicago State University, April 14, 2010, "Biologically inspired sensors", Williams science center. Host: Austin Harton.
46. University of Southern California, ENH Seminar Series: Monday, May 10 2010 "Biologically inspired artificial haircell sensors", May 19, 2010. Host: Francisco Valero.
47. Electrical Engineering department, University of Wisconsin at Madison, "Bioinspired sensors", Host: Hongrui Jiang, Monday September 20, 2010.
48. University of Bonn, GK Bionik 1572 Seminars, Oct 23, 2010, "Biologically Inspired Sensors Based on Haircells and Laterals"
49. Invited talk, "Biological inspired haircell sensors", Chinese Society of Micro and Nano Technology, October 22, 2010, Xian China.

### Media Coverage

1. Research/Researchers news section, "Magnetic actuation folds microparts into 3D structures", MRS Bulletin, June 2000, Vol. 25, No. 7.
2. "Illinois researcher develops magnetic actuation technique," Journal of Materials (JOM), a publication of TMS, July 2000.
3. "Biodegradable MEMS", Physics World, Vol. 13, No. 4, April 2000.
4. "Hairy space probes", New Scientist, pp. 30-33, September 9, 2000.
5. "Magnetic parallel assembly improves 3D processing", Semiconductor International, Vol. 23, No. 6, June 2000.
6. "Magnetic actuation enables three-dimensional MEMS", EE Times, May 16, 2000.
7. "Magnets build tiny machines", Vacuum Solutions, Issue 16, July/August 2000.
8. "Computers grow hair to become smarter", Science and Technology section, Business Week, 5/2000.
9. "Das seitenlinienorgan der fische konnte bei der navigation von tiefseero otern helfen", Wissenschaft online, Germany, June 26, 2002. (English translation of title: The side-line organs of fish could help in the navigation of deep sea robots.)
10. Greg Cline, "Lab on a chip offers early-warning possibilities," News Gazette, December 23, 2001.
11. "Touchy touchy," The Economist, August 10, 2002 issue.
12. "Imitating nature is the sincerest form of flattery," Forbes ASAP magazine, Fall 2002 issue.
13. G. Kline, "Brick Is No Dummy," *The News-Gazette*. Champaign-Urbana, 2003, p. B-1.
14. N. Moffett, "Thick as a brick? U. of I. invents one that thinks," in *The Chicago Sun-Times*. Chicago, IL, 2003.
15. Jim Kloeppe, "Smart Bricks could monitor buildings, save lives", University of Illinois News Bureau release, June 12, 2003.
16. "Smart' brick sends structural data to computer", USA Today, July 21, 2003.
17. Greg Kline, "U of I researchers develops smart brick," St. Louis Post Dispatch, July 27, 2003.
18. Other coverage of smart brick news: BBC Science Radio, Wired Magazine, Business Week, Architecture.com, etc.
19. G. Kline, "Thinking Small on a Bigger Scale," *The News-Gazette*. Champaign-Urbana, February 3, 2005
20. "Smart Brick," History Channel, may 11, 2005
21. "Flexible Tactile Sensors Could Help Robots Work Better," UIUC News Bureau, May 19, 2005
22. "Flexible Tactile Sensors Could Help Robots Work Better," UIUC College of Engineering, May 20, 2005
23. "Flexible Tactile Sensors Could Help Robots Work Better," Science Daily, May 20, 2005

24. "Researchers Developing Artificial Sense of Touch for Robotics" Linux Electronics, May 21, 2005
25. "Flexible tactile sensors could boost robots sensitivity to touch" Science and nature, May 23, 2005
26. "Skin' could refine robots' sense of touch" EE times, may 30, 2005
27. "New prescription: Antidotes for radiation," Chicago Tribune, June 6, 2005
28. "A touchy Mission: Helping Robots Feel," *The News-Gazette*. Champaign-Urbana, June 5, 2005.
29. "Artificial arrays could help submarines make like a fish," NewsFocus, Science, Vol. 313, 1382-1384, September 8, 2006.

**Issued Patents** (12 US patent disclosure and applications)

1. Y. Yi and C. Liu, "A Method for Assembly of Microelectromechanical Systems Using Magnetic Actuation" US Patent No 6,166,478 issued December 26, 2000
2. C. Liu, J. Zou, "Wide Tuning Range Variable MEMS Capacitor," US Patent No 6,418,006 issued July 9, 2002
3. C. Liu, M. Zhang, and D. A. Bullen, "Parallel, Individually Addressable Probes for Nanolithography" US Patent No 6,642,129 issued November 4, 2003
4. C. Liu, "Sensor for Monitoring Material Deposition and Method of Monitoring Material Deposition" US Patent No 6,884,458 issued April 26, 2005
5. J. Zou, C. Liu, J. Schutt-Aine, "Raised On-Chip Inductor and Method of Manufacturing Same," US Patent No 6,922,127 issued July 26, 2005
6. C. Liu and J. Chen, "Microscale Out-of-Plane Anemometer" US Patent No. 6,923,054 issued August 2, 2005
7. Chang Liu, Jun Zou, Xuefeng Wang, David Bullen, Scanning probe microscopy probes and methods, US Patent 7,081,624 July 25, 2006.
8. Chang Liu, Gary Eden, etc "Microdischarge devices and arrays having tapered microcavities," 7,112,918, September 26, 2006.

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